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	Application No.	Applicant(s)
N. C F. All L. 194	10/643,062	RICHARDS ET AL.
Notice of Allowability	Examiner	Art Unit
	Edna Wong	1753
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT F of the Office or upon petition by the applicant. See 37 CFR 1.31	S (OR REMAINS) CLOSED in i) or other appropriate communication is sommunication in sommuni	this application. If not included unication will be mailed in due course. THIS
1. $igspace$ This communication is responsive to <u>Amendment After Fi</u>	inal dated November 28, 2000	<u>6</u> .
2. 🔀 The allowed claim(s) is/are <u>3,7-9,19,22 and 23</u> .		
 3. ☐ Acknowledgment is made of a claim for foreign priority t a) ☐ All b) ☐ Some* c) ☐ None of the: 1. ☐ Certified copies of the priority documents have 		or (f).
2. Certified copies of the priority documents hav		n No.
3. ☐ Copies of the certified copies of the priority do	, ,	
International Bureau (PCT Rule 17.2(a)).		3. opp.
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONI THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		a reply complying with the requirements
4. A SUBSTITUTE OATH OR DECLARATION must be subr INFORMAL PATENT APPLICATION (PTO-152) which give	mitted. Note the attached EXA ves reason(s) why the oath or	AMINER'S AMENDMENT or NOTICE OF declaration is deficient.
5. CORRECTED DRAWINGS (as "replacement sheets") mu	ust be submitted.	•
(a) including changes required by the Notice of Draftsper		v (PTO-948) attached
1) 🗌 hereto or 2) 🗍 to Paper No./Mail Date		
(b) ☐ including changes required by the attached Examiner Paper No./Mail Date	r's Amendment / Comment or	in the Office action of
Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in		
 DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT 		
Attachment(s)	- 5	
1. Notice of References Cited (PTO-892)		formal Patent Application
 Notice of Draftperson's Patent Drawing Review (PTO-948) 		ummary (PTO-413), Mail Date
Information Disclosure Statements (PTO/SB/08), Paper No./Mail Date		Amendment/Comment
Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. 🛭 Examiner's	Statement of Reasons for Allowance
or biological material	9.	
		Some Word.
		EDNA WONG PRIMARY EXAMINER

U.S. Patent and Trademark Office PTOL-37 (Rev. 08-06) Application/Control Number: 10/643,062

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REASONS FOR ALLOWANCE

The following is an examiner's statement of reasons for allowance:

Claims 3, 7-9, 19 and 22-23 are allowable over the prior art of record because the prior art does not teach or suggest a method of removing ammonia from an effluent gas stream comprising the steps of (a) irradiating, (b) substantially reducing, (c) initiating and (d) maintaining as presently claimed, esp., the steps of (a) irradiating with ultraviolet light a gas stream produced by an industrial process where the gas stream emitted from the industrial process contains ammonia at concentrations less than 40 ppm; and (d) maintaining a NO_x concentration in the gas stream at a concentration level sufficient to maintain in the gas stream the active set of hydroxyl and hydroperoxy free radical reactions. The prior art does not contain any language that teaches or suggests the above. Stevens does not teach where the gas stream emitted from the industrial process contains ammonia at concentrations less than 40 ppm, and maintaining a NO_x concentration in the gas stream at a concentration level sufficient to maintain in the gas stream the active set of hydroxyl and hydroperoxy free radical reactions. Stevens main occurring reactions are NO_x-removing reactions of equations (1), (2) and (3), which results in the formation of N_2O , H_2O and N_2 (col. 2, lines 3-11).

Therefore, a person skilled in the art would not have been motivated to adopt the above conditions, and a prima facie case of obviousness cannot be established.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably Application/Control Number: 10/643,062

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accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Edna Wong whose telephone number is (571) 272-1349. The examiner can normally be reached on Mon-Fri 7:30 am to 4:00 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nam Nguyen can be reached on (571) 272-1342. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

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December 8, 2006